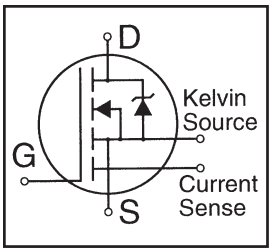
International
IOR Rectifier

IRCZ44

HEXFET® Power MOSFET

- Dynamic dv/dt Rating
- Current Sense
- 175°C Operating Temperature
- Fast Switching
- Ease of Paralleling
- Simple Drive Requirements



V_{DSS} = 60V

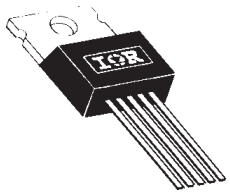
$R_{DS(on)}$ = 0.028Ω

I_D = 50*A

Description

Third Generation HEXFETs from International Rectifier provide the designer with the best combination of fast switching, ruggedized device, low on-resistance and cost-effectiveness.

The HEXSence device provides an accurate fraction of the drain current through the additional two leads to be used for control or protection of the device. These devices exhibit similar electrical and thermal characteristics as their IRF-series equivalent part numbers. The provision of a kelvin source connection effectively eliminates problems of common source inductance when the HEXSence is used as a fast, high-current switch in non current-sensing applications.



TO-220 HexSense

Absolute Maximum Ratings

Parameter		Max.	Units
I_D @ T_C = 25°C	Continuous Drain Current, V_{GS} @ 10V	50*	A
I_D @ T_C = 100°C	Continuous Drain Current, V_{GS} @ 10V	37	
I_{DM}	Pulsed Drain Current ①	210	
P_D @T_C = 25°C	Power Dissipation	150	W
	Linear Derating Factor	1.0	W/°C
V_{GS}	Gate-to-Source Voltage	±20	V
E_{AS}	Single Pulse Avalanche Energy ②	30	mJ
dv/dt	Peak Diode Recovery dv/dt ③	4.5	V/ns
T_J T_{STG}	Operating Junction and Storage Temperature Range	-55 to + 175	℃
	Soldering Temperature, for 10 seconds	300 (1.6mm from case)	
	Mounting Torque, 6-32 or M3 screw	10 lbf•in (1.1 N•m)	

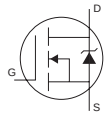
Thermal Resistance

	Parameter	Min.	Typ.	Max.	Units
$R_{\theta JC}$	Junction-to-Case	—	—	1.0	°C/W
$R_{\theta CS}$	Case-to-Sink, Flat, Greased Surface	—	0.50	—	
$R_{\theta JA}$	Junction-to-Ambient —	—	—	62	

Electrical Characteristics @ T_J = 25°C (unless otherwise specified)

	Parameter	Min.	Typ.	Max.	Units	Conditions
$V_{(BR)DSS}$	Drain-to-Source Breakdown Voltage	60	—	—	V	V_{GS} = 0V, I_D = 250µA
$\Delta V_{(BR)DSS}/\Delta T_J$	Breakdown Voltage Temp. Coefficient	—	0.060	—	V/°C	Reference to 25°C, I_D = 1mA
$R_{DS(ON)}$	Static Drain-to-Source On-Resistance	—	—	0.028	Ω	V_{GS} = 10V, I_D = 31A④
$V_{GS(th)}$	Gate Threshold Voltage	2.0	—	4.0	V	V_{DS} = V_{GS}, I_D = 250µA
g_{fs}	Forward Transconductance	18	—	—	S	V_{DS} = 25V, I_D = 31A
I_{DSS}	Drain-to-Source Leakage Current	—	—	25		V_{DS} = 60V, V_{GS} = 0V
		—	—	250		V_{DS} = 48V, V_{GS} = 0V, T_J = 150°C
I_{GSS}	Gate-to-Source Forward Leakage	—	—	100		V_{GS} = 20V
	Gate-to-Source Reverse Leakage	—	—	-100		V_{GS} = -20V
Q_g	Total Gate Charge	—	—	95		I_D = 52A
Q_{gs}	Gate-to-Source Charge	—	—	27	nC	V_{DS} = 48V
Q_{gd}	Gate-to-Drain ("Miller") Charge	—	—	46		V_{GS} = 10V, See Fig. 6 and 13 ④
$t_{d(on)}$	Turn-On Delay Time	—	19	—		V_{DD} = 30V
t_r	Rise Time	—	120	—		I_D = 52A
$t_{d(off)}$	Turn-Off Delay Time	—	55	—		R_G = 9.1Ω
t_f	Fall Time	—	86	—		R_D = 0.54Ω, See Fig. 10 ④
L_D	Internal Drain Inductance	—	4.5	—	nH	Between lead, 6 mm (0.25in.) from package and center of die contact
L_C	Internal Source Inductance	—	7.5	—		
C_{iss}	Input Capacitance	—	2500	—		V_{GS} = 0V
C_{oss}	Output Capacitance	—	1200	—	pF	V_{DS} = 25V
C_{rss}	Reverse Transfer Capacitance	—	200	—		f = 1.0MHz, See Fig. 5
r	Current Sensing Ratio	2460	—	2720	—	I_D = 52A, V_{GS} = 10V
C_{oss}	Output Capacitance of Sensing Cells	—	9.0	—	pF	V_{GS} = 0V, V_{DS} = 25V, f = 1.0MHz

Source-Drain Ratings and Characteristics

	Parameter	Min.	Typ.	Max.	Units	Conditions
I_S	Continuous Source Current (Body Diode)	—	—	50*	A	MOSFET symbol showing the integral reverse p-n junction diode. 
I_{SM}	Pulsed Source Current (Body Diode) ①	—	—	210		
V_{SD}	Diode Forward Voltage	—	—	2.5	V	T_J = 25°C, I_S = 52A, V_{GS} = 0V ④
t_{rr}	Reverse Recovery Time	—	140	300	ns	T_J = 25°C, I_F = 52A
Q_{rr}	Reverse Recovery Charge	—	1.2	2.8	nC	di/dt = 100A/µs ④
t_{on}	Forward Turn-On Time	Intrinsic turn-on time is negligible (turn-on is dominated by L_S+L_D)				

Notes:

① Repetitive rating; pulse width limited by max. junction temperature. (See fig. 11)

② V_{DD} = 25V, starting T_J = 25°C, L = 0.013mH R_G = 25Ω, I_{AS} = 52A. (See Figure 12)

③ I_{SD} ≤ 52A, di/dt ≤ 250A/µs, V_{DD} ≤ $V_{(BR)DSS}$, T_J ≤ 175°C

④ Pulse width ≤ 300µs; duty cycle ≤ 2%.

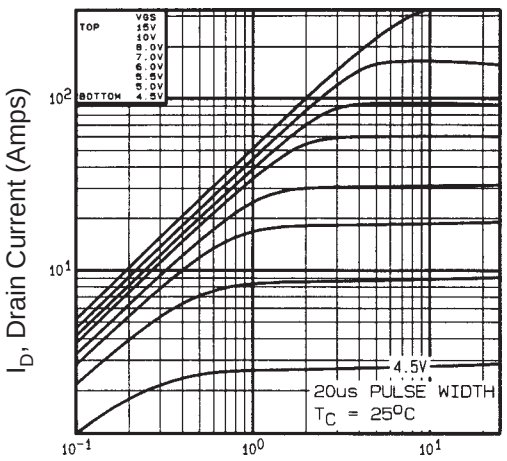


Fig. 1 Typical Output Characteristics, T_C=25°C

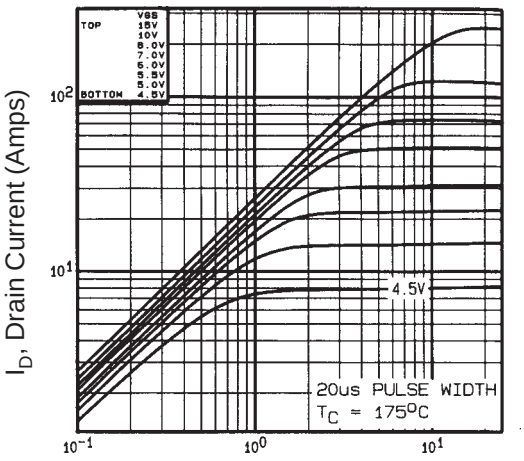


Fig. 2 Typical Output Characteristics, T_C=175°C

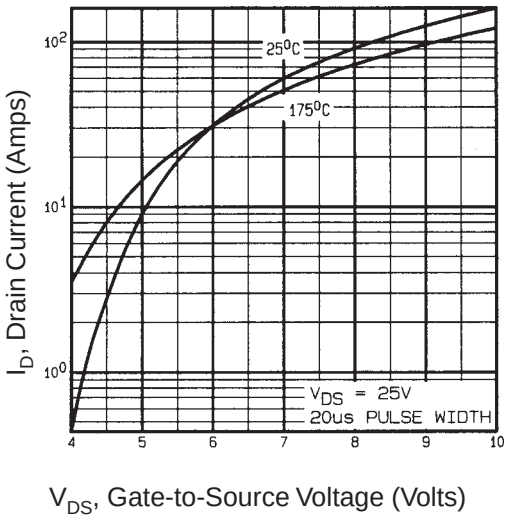


Fig. 3 Typical Transfer Characteristics

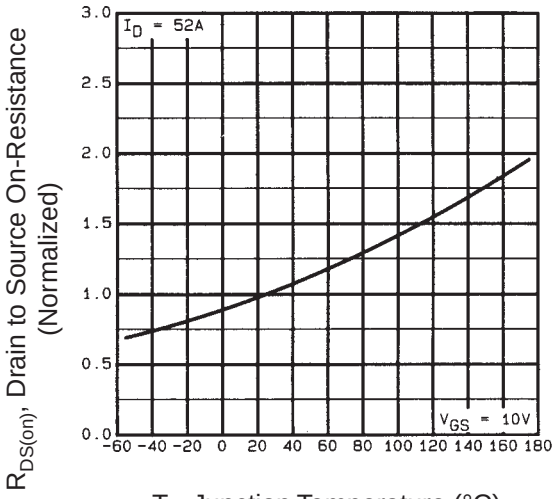
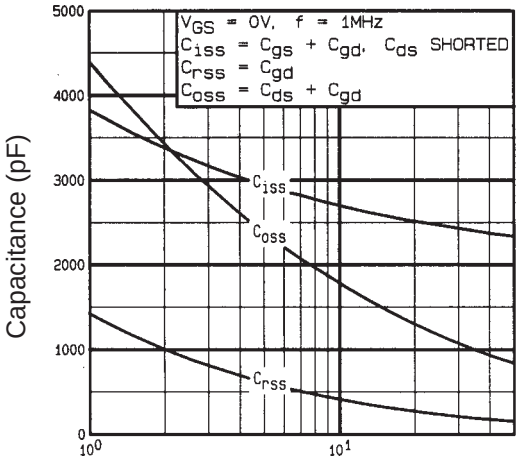
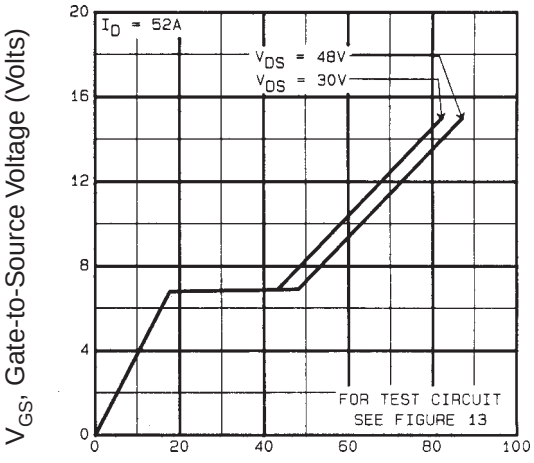


Fig. 4 Normalized On-Resistance vs. Temperature



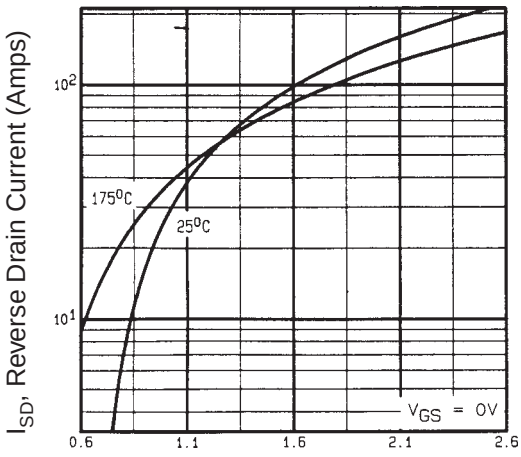
V_{DS}, Drain-to-Source Voltage (Volts)

Fig. 5 Typical Capacitance vs. Drain-to-Source Voltage



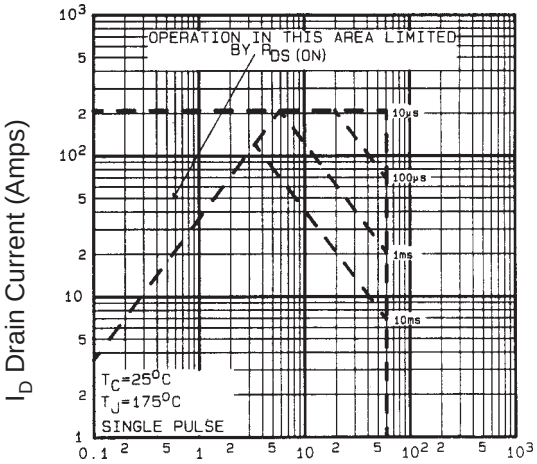
Q_G, Total Gate Charge (nC)

Fig. 6 Typical Gate Charge vs. Gate-to-Source Voltage



V_{SD}, Source-to-Drain Voltage (Volts)

Fig. 7 Typical Source-Drain Diode Forward Voltage



V_{DS}, Drain-to-Source Voltage (Volts)

Fig. 8 Maximum Safe Operating Area

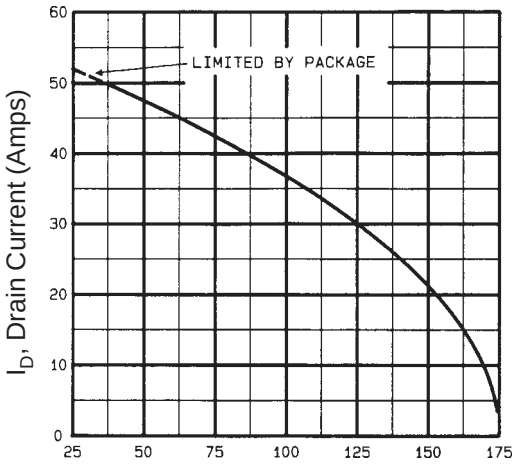


Fig. 9 Maximum Drain Current vs. Case Temperature

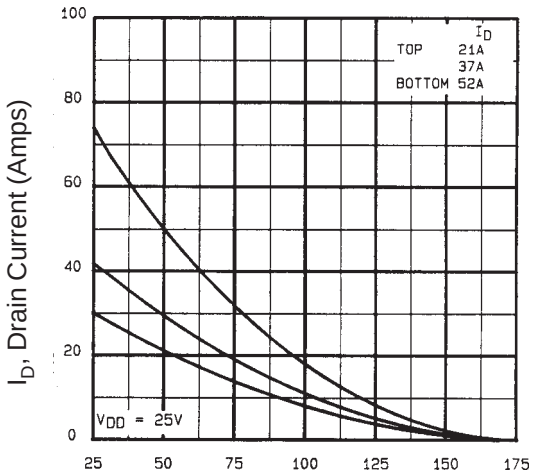


Fig. 12c Maximum Avalanche Energy vs. Drain Current

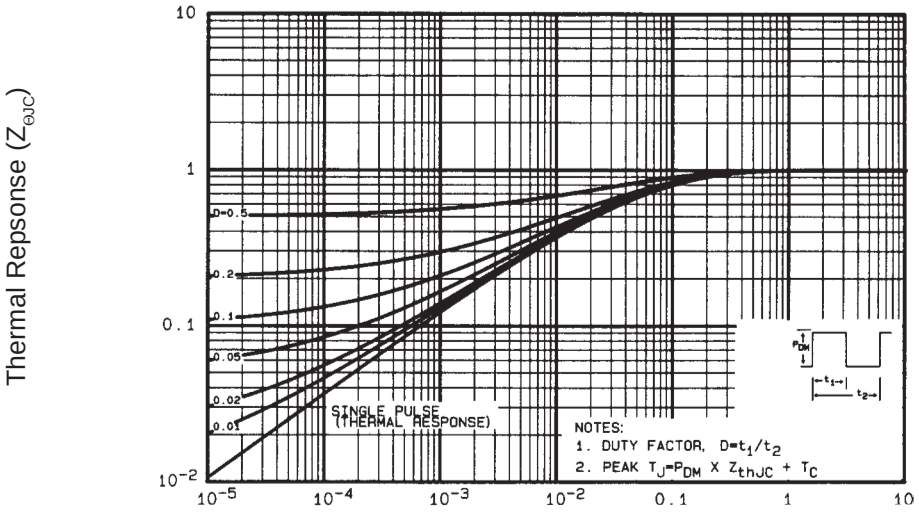


Fig. 11 Maximum Effective Transient Thermal Impedance, Junction-to-Case

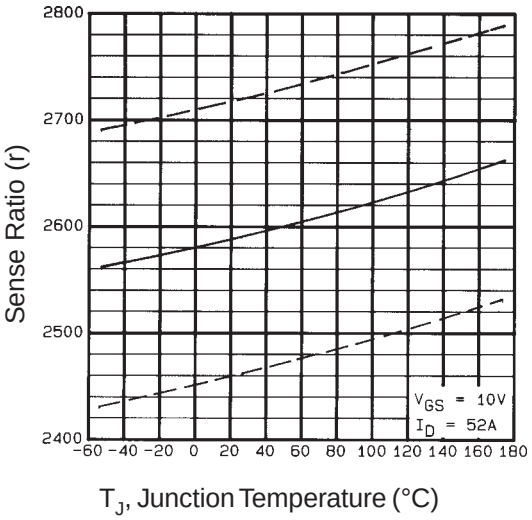


Fig. 15 Typical HEXSense Ratio vs. Junction Temperature

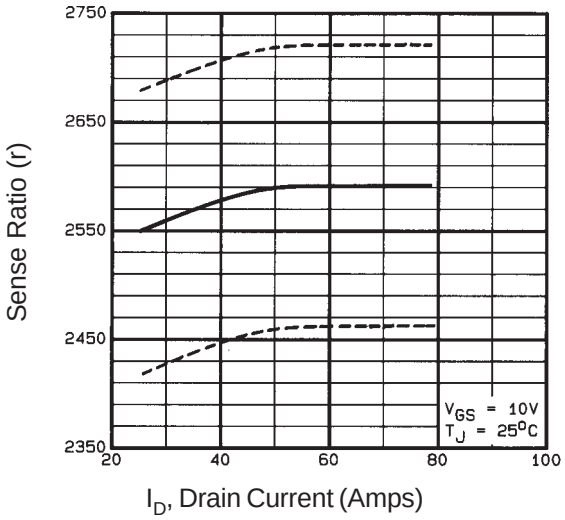


Fig. 16 Typical HEXSense Ratio vs. Drain Current

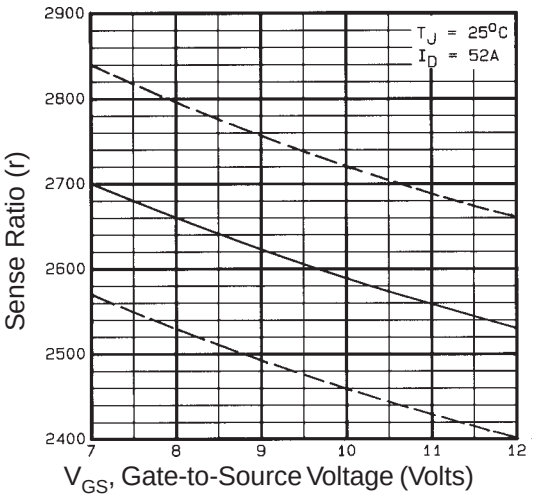


Fig. 17 Typical HEXSense Ratio vs. Gate Voltage

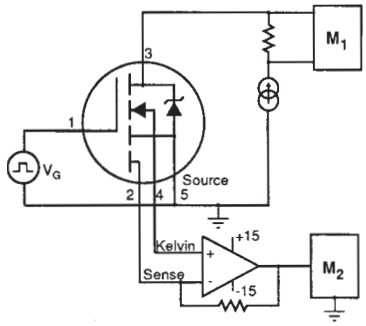


Fig. 18 HEXSense Ratio Test Circuit

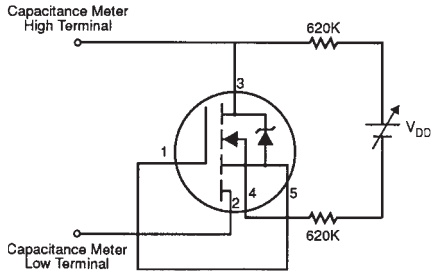


Fig. 19 HEXSense Sensing Cell Output Capacitance Test Circuit

Mechanical drawings, Appendix A
Part marking information, Appendix B
Test Circuit diagrams, Appendix C